

<b>Notice of References Cited</b>	Application/Control No. 10/723,750	Applicant(s)/Patent Under Reexamination BECKER-SZENDY ET AL.	
	Examiner Thanh-Ha Dang	Art Unit 2163	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,938,039	08-2005	Bober et al.	707/8
*	B	US-2004/0030731	02-2004	Iftode et al.	707/205
*	C	US-2003/0078946	04-2003	Costello et al.	707/201
*	D	US-2005/0021502	01-2005	Chen et al.	707/002
*	E	US-7,024,427	04-2006	Bobbitt et al.	707/200
*	F	US-2004/0193630	09-2004	McLauchlin, Andrew William	707/100
*	G	US-2005/0226059	10-2005	Kavuri et al.	365/189.05
*	H	US-2005/0044162	02-2005	Liang et al.	709/212
*	I	US-2005/0015384	01-2005	Wehrman et al.	707/100
*	J	US-2004/0255048	12-2004	Lev Ran et al.	709/249
*	K	US-2004/0210644	10-2004	Prust, Mitch	709/219
*	L	US-2003/0191838	10-2003	Tsao, Sheng (Ted) Tai	709/225
*	M	US-5,367,698	11-1994	Webber et al.	709/203

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.